

Docket No. 740819-466

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Takumi MIKAWA et al.

Application No. 09/734,176

Filed: December 12, 2000

For: SEMICONDUCTOR DEVICE AND
METHOD FOR FABRICATING THE
SAME

)

) Group Art Unit: 2811

) Examiner: Steven Ho Yin Loke

) Confirmation No. 5101

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Angelique Graham

AMENDMENT

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action mailed March 29, 2004, please consider the amendments and remarks in connection with the above-identified application as follows.

NVA301550.1